

Title (en)
PROCESS APPARATUS, IN PARTICULAR FOR PROCESSING AND/OR INSPECTING SUBSTRATES

Title (de)
PROZESSMASCHINE, INSBESONDERE ZUM BEARBEITEN UND/ODER INSPIZIEREN VON SUBSTRATEN

Title (fr)
APPAREIL DE TRAITEMENT, NOTEMMENT POUR LE TRAITEMENT ET L'INSPECTION DES SUBSTRATS

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Application
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Abstract (en)
[origin: WO2012048771A1] The invention relates to a process machine, in particular for treating and/or inspecting substrates (16), in particular boards, printed circuit boards, solar cells or the like, having at least one transport device (1) for transporting the substrates and having at least one process device (2) for processing, in particular for treating and/or inspecting, the substrates. Provision is made for the transport device and the process device to be in the form of separate, respectively independent modular units (42), wherein the modular units can be selectably combined with one another in such a manner that the transport device transports the substrates through the process device. The invention also relates to a method directed to inspecting and/or printing substrates, in particular boards, printed circuit boards, solar cells or the like, with at least one transport device for transporting the boards and at least one process device for treating and/or inspecting the substrates, wherein the transport device and the process device can be combined, as separate, respectively independent modular units, in such a manner that the transport device transports the substrates through the process device.

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Citation (search report)
See references of WO 2012048771A1

Citation (examination)
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